



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Hong-Sik Jeong et al. Serial No.: 10/008,700

Filed: December 7, 2001

Confirmation No.: 5150 Group Art Unit: 2825 Examiner: Chuong A. Luu

METHODS OF MANUFACTURING INTEGRATED CIRCUIT DEVICES

HAVING AN ENCAPSULATED INSULATION LAYER

Date: July 22, 2003

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

For:

Applicant provides the present Amendment to address the issues raised in the Official Action mailed April 24, 2003 ("the Action"). The present amendment is provided in the Revised Amendment Format as published in the Official Gazette on February 25, 2003. The Revised Amendment Format waives certain requirements of 37 CFR 1.121.

TECHNOLOGY CENTER 2800